Certification under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Assistant Commissioner of Patents, Washington, D.C. 20231 on February 26, 2002.

Brian W. Hameder (Reg. No. 45,613) Name

DOCKET: CU-2727

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hideshi HATTORI

Serial No.: 10/018,718

Group Art Unit:

Filed: December 14, 2001

Examiner:

For: ANTIREFLECTION FILM AND METHOD FOR MANUFACTURING THE SAME

THE ASSISTANT COMMISSIONER FOR PATENTS

Washington, D.C. 20231

## TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of the first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(b).

Date: February 26, 2002

Signature of Attorney Brian W. Hameder Ladas & Parry 224 South Michigan Avenue Chicago Illinois 60604 Tel. No. (312) 427-1300 Reg. No. 45613

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Assistant Commissioner of Patents, Washington, D.C. 20231 on February 26, 2002.

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#### INFORMATION DISCLOSURE STATEMENT

Applicants submit herewith patents, publications or other information of which the applicants are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose under 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

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The references submitted herein are listed on PTO-1449 form (modified) enclosed herewith. A copyof each reference listed is being furnished except any duplicate or cumulative patents or publications specified otherwise.

A translation of any foreign language reference, if any, is indicated in PTO-1449 form and being submitted herein if it is readily available. Otherwise it should be construed that such translation is not readily available.

Also submitted herein is a copy of the International search report which satisfies the requirement for a concise explanation of any non-English reference cited therein, as provided in MPEP §609 A(3).

Additional comments, if any, on the relevance of each reference listed are provided as follows:

The Statement is made on the basis of the information:

supplied by the inventor(s);
supplied by an individual associated with the filing and prosecution of this application (37 CFR 1.56(c)); or in the attorney's file.

Respectfully submitted,

Date: February 26, 2002

Signature of Attorney
Brian W. Hameder
Ladas & Parry
224 South Michigan Avenue
Chicago Illinois 60604
Tel. No. (312) 427-1300
Reg. No. 45613

# Form PTO-1449 (Modified)MAR 0 4 2002

FORM PTO-1449

PADEMARKS

ATTY, DOCKET NO. CU-2727

SERIAL NO. 10/018,718

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

APPLICANT Hideshi HATTORI

FILING DATE
December 14, 2001

GROUP

(37 CFR 1.98(b))

## **U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		PA	ΓEN	ΤN	IUN	1BE	R	ISSUE DATE	PATENTEE	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
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FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

EXAMINER INITIAL		D	ocı	JME	NT	NÚN	иве	R	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB- CLASS	TRANSLATION YES   NO	
		5	2	9	0	6	3	4	11/05/93	Japan			X	
_		9	2	2	2	5	0	3	08/26/97	Japan			X	
	200	0	2	7	6	9	4	1	10/06/00	Japan			X	
		7	1	6	8	0	0	4	07/04/95	Japan			X	

OTHER DOCUMENTS (Including Author, Title, Date, Place of publication)

		Katsuhiko Ariga, Yuri Lvov, Mitsuhiko Onda, Izumi Ichinose and Toyoki Kunitake, Alternately Assembled Ultrathin Film of Silica Nanoparticles and Linear Polycations, Chemistry Letters, Chemical Society of Japan, 1997, No. 2, pages 125 and 126									
	/	Takeshi Serizawa, Hiroko Takeshita, and Mitsuru Akashi, Electric Adsorption of Pollystyrene Nanospheres onto the Surface of an Ultrathin Polymer Film Prepared by Using an Alternate Adsorption Technique, Langmuir, American Chemical Society, April 1998, Vol. 14, pages 4088 and 4089									

EXAMINER

DATE CONSIDERED

EXAMINER: Initial citation considered. Draw line through citation if not In conformance and not considered. Include copy of this form with next communication to applicant.

(Form PTO-1449)

